WEST Search History

Hide Items Restore Clear Cancel

DATE: Monday, May 21, 2007

Hide?	<u>Set</u> <u>Name</u>	Query	<u>Hit</u> Count
	DB=P	GPB, USPT, USOC, EPAB, JPAB, DWPI; PLUR=YES; OP=ADJ	
	L10	(cup same (vessel or chamber) same (object or substrate or semiconductor or wafer or workpiece) same (first with nozzle) same (second with nozzle) same (third with nozzle))	5
	L9	L7 and (cup same (vessel or chamber) same (object or substrate or semiconductor or wafer or workpiece) same (first with nozzle) same (second with nozzle) same (third with nozzle))	0
	L8	L7 and (cup same (vessel or chamber) same (object or substrate or semiconductor or wafer or workpiece) same (first adj nozzle) same (second adj nozzle) same (third adj nozzle))	0
	L7	L6 or 15 or 14 or 11	25155
	L6	(ebara).as.	25131
	L5	miyashita-mitsuo\$.in.	16
	L4 .	L3	50
	L3	nishioka-yukiko\$.in.	50
	L2	nishiooka-yukiko\$.in.	0
	L1	yonekura-ryosuke\$.in.	. 5

END OF SEARCH HISTORY